

RECC

08-01-2001

HEET



Tab settings

To the Honorable Commissioner of Patents and Trademarks
101794355

Send original documents or copy thereof.

1. Name of conveying party(ies): 7-2601
Toshiaki FUJII
Yasuhiko SUGIYAMA
Toshio DOI
Additional name(s) of conveying party(ies) attached? Yes No

2. Name and address of receiving party(ies)
Name: Seiko Instruments Inc.
Internal Address: _____

Street Address: 8, Nakase 1-chome,
Mihama-ku, Chiba-shi
City: Chiba State: Japan ZIP: _____
Additional name(s) & address(es) attached? Yes No

3. Nature of conveyance:
 Assignment Merger
 Security Agreement Change of Name
 Other _____
Execution Date: June 26, 2001

4. Application number(s) or patent number(s):
If this document is being filed together with a new application, the execution date of the application is: _____
A. Patent Application No.(s) 09/207,823 B. Patent No.(s) _____
Additional numbers attached? Yes No

5. Name and address of party to whom correspondence concerning document should be mailed:
Name: Bruce L. Adams
Internal Address: _____

Street Address: Adams & Wilks
50 Broadway-31st Floor
City: New York State: NY ZIP: 10004

6. Total number of applications and patents involved: 1
7. Total fee (37 CFR 3.41).....\$ 40.00
 Enclosed
 Authorized to be charged to deposit account any deficiency in enclosed fee
8. Deposit account number: 01-0268
(Attach duplicate copy of this page if paying by deposit account)

08/01/2001 LHMELLER 00000026 09207823

DO NOT USE THIS SPACE

01 FC:581

40.00 BP

9. Statement and signature.
To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.
Bruce L. Adams [Signature]
Name of Person Signing Signature
Date: July 20, 2001

Total number of pages including cover sheet, attachments, and document: 3

ASSIGNMENT

WHEREAS, we, Toshiaki Fujii, Yasuhiko Sugiyama and Toshio Doi residing at c/o Seiko Instruments Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan have invented new and useful improvements in FOCUSED ION BEAM MACHINING METHOD AND DEVICE
THEREOF

for which we have prepared an application for Letters Patent of the United States of America;

AND WHEREAS, Seiko Instruments Inc., located and doing business at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor;

NOW, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to us in hand paid, the receipt of which is hereby acknowledged, we have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said Seiko Instruments Inc. for the territory of the United States of America, our entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by us on January 26, 1999, filed December 9, 1998, Serial No. 09/207,823, preparatory to obtaining Letters Patent thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said Seiko Instruments Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by us had this assignment, sale and transfer not been made.

AND, we hereby covenant and agree that we will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and we hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said Seiko Instruments Inc. in accordance with this assignment.

Executed this 26th day of June, 2001 at

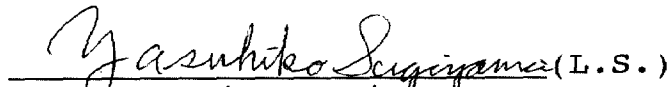
_____.

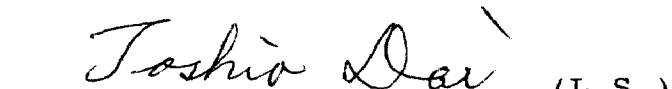
Witness:



 Masaki Hori


 _____ (L.S.)
 Toshiaki Fujii


 _____ (L.S.)
 Yasuhiko Sugiyama


 _____ (L.S.)
 Toshio Doi